

Day: Monday Date: 4/23/2007

Time: 06:43:53

IFW Madras

Secrecy Order: NO

## **Application Number Information**

Application Number: 10/584729

**Assignments** 

Filing or 371(c) Date: 00/00/0000 eDan

Effective Date: 06/23/2006

Application Received: 06/23/2006

Patent Number:

Issue Date: 00/00/0000

Date of Abandonment: 00/00/0000

Attorney Docket Number: 0756-7709

Status: 19 /APPLICATION UNDERGOING PREEXAM PROCESSING Status Date: 07/12/2006

Oral Hearing: NO Confirmation Number: 6076

Title of Invention: LASER IRRADIATION METHOD, LASER IRRADIATION APPARATUS

Examiner Number: 00000 /

Class/Subclass: 438/151.000

Group Art Unit: 2812

Interference Number:

Unmatched Petition: NO

Third Level Review: NO

L&R Code: Secrecy Code:1

Lost Case: NO

AND METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE

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